

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Makoto IIDA

ATTN: Mail Stop PCT

Application No.: 10/586,476

Docket No.: 128768

Filed: July 18, 2006

For: A METHOD FOR PRODUCING SEMICONDUCTOR WAFERS AND A SYSTEM
FOR DETERMINING A CUT POSITION IN A SEMINCONDUCTOR INGOT

NOTIFICATION OF ACCEPTANCE AND FILING RECEIPT STATUS REQUEST

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

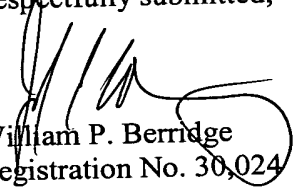
Sir:

The above-captioned patent application entered the National Phase on July 18, 2006. The 35 U.S.C. 371 requirements were completed on July 18, 2006.

The original Notification of Acceptance and Filing Receipt have not yet been received. It is respectfully requested that the original Notification of Acceptance and Filing Receipt be immediately forwarded to the attorneys of record at the address set forth below.

If there are any questions regarding this matter, please contact the undersigned at the telephone number set forth below.

Respectfully submitted,


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Date: December 18, 2006

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